

Session Program

1 May 2023 to 1 July 2023

Advanced UK Instrumentation Training 2023

Silicon fabrication and structures

Tuesday 2 May

15:00

16:00

Silicon fabrication and structures

Session | Location:

15:00-16:00

Device fabrication 1

Speaker

Andrew Blue

Friday 5 May

11:00

12:00

Silicon fabrication and structures

Session | Location:

11:00-12:00

Device fabrication 2

Speaker

Andrew Blue

Tuesday 9 May

15:00

16:00

Silicon fabrication and structures

Session | Location:

15:00-16:00

Device fabrication 3

Speaker

Enrico Giulio Villani

Friday 12 May

12:00

13:00

Silicon fabrication and structures

Session | Location:

12:00-13:00

Device fabrication 4

Speaker

Enrico Giulio Villani

Tuesday 16 May

15:00

16:00

Silicon fabrication and structures

Session | Location:

15:00-16:00

Device structures: planar and 3D

Speaker

Francisca Munoz Sanchez

Friday 19 May

11:00

12:00

Silicon fabrication and structures

Session | Location:

11:00-12:00

Device structures: Gain Layers (LGAD, SPAD, SiPM)

Speaker

Francisca Munoz Sanchez

Tuesday 23 May

15:00

16:00

Silicon fabrication and structures

Session | Location:

15:00-16:00 **Device structures: monolithic**

Speaker

Eva Vilella Figueras

Friday 26 May

12:00

13:00

Silicon fabrication and structures

Session | Location:

12:00-13:00

Transistor layout: 250 - 28 nm, FinFETs

Speaker

Eva Vilella Figueras